

<b>Notice of References Cited</b>	Application/Control No. 10/802,772	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Tai Duong	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,102,162	09-2006	Mai, Che-Kuei	257/59
*	B	US-6,724,358	04-2004	Ban et al.	345/92
*	C	US-6,482,479	11-2002	Dubal et al.	428/1.1
*	D	US-5,998,101	12-1999	Park et al.	430/321
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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